

DR

Docket No.: 43889-929



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
 Toyokazu FUJII, et al. : Confirmation Number: 5999
 Application No.: 09/536,618 : Group Art Unit: 2814
 Filed: March 28, 2000 : Examiner: PHAM, Hoai V.

For: SEMICONDUCTOR DEVICE AND PROCESS FOR FABRICATION OF THE SAME

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- No additional fee is required.
 Applicant is entitled to small entity status under 37 CFR 1.27
 Also attached:

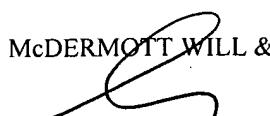
The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	31	31	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
Multiple claims newly presented				\$0.00	
Fee for extension of time				\$0.00	
				\$0.00	
Total of Above Calculations				\$0.00	

- Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP


 Michael E. Fogarty
 Registration No. 36,139

Please recognize our Customer No. 20277 as our correspondence address.

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 Date: January 26, 2005

WDC99 1034149-1.043889.0929

ATTORNEY DOCKET NO. 43889-929
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Toyokazu FUJII, et al.

Serial No.: 09/536,618
(DIV of SN: 09/018,181)

Filed: March 28, 2000

: Customer No.: 20277
: Confirmation No.: 5999
: Group Art Unit: 2814
: Examiner: H. PHAM

For: A SEMICONDUCTOR DEVICE HAVING IMPROVED PLANARIZATION
PROPERTIES AND A METHOD FOR FORMING THE SAME (AS AMENDED)

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 7, 2004, having a shortened statutory period for response set to expire March 7, 2005, please amend the above-identified application as follows:

